

## EAST Search History

Ref #	Hits	Search Query	DBs	Default Operator	Plurals	Time Stamp
S2	179	96/4-14.ccls. and etch\$3	US-PGPUB; USPAT	OR	OFF	2008/08/15 10:38
S3	111	95/45-55.ccls. and etch\$3	US-PGPUB; USPAT	OR	OFF	2008/08/15 11:07
S7	111	(96/4-14 95/45- 55).ccls. and etch\$3 and ceramic\$1	US-PGPUB; USPAT	OR	OFF	2008/08/15 11:42
S10	59	membrane same etch\$3 with silicon same ceramic\$1	US-PGPUB; USPAT	OR	OFF	2008/08/15 11:43
S13	80	membrane with chamber\$1 and etch\$3 with silicon same ceramic\$1	US-PGPUB; USPAT	OR	OFF	2008/08/15 11:54
S15	2	96/11.ccls. and (ceramic carbide \$1 nitride\$1) same reinforc\$5	US-PGPUB; USPAT	OR	OFF	2008/08/15 11:56
S16	27	96/11.ccls. and (ceramic carbide \$1 nitride\$1) same crystal\$6	US-PGPUB; USPAT	OR	OFF	2008/08/15 11:56
S17	2	96/11.ccls. and (ceramic carbide \$1 nitride\$1) same isostatic	US-PGPUB; USPAT	OR	OFF	2008/08/15 11:59
S18	1	(96/4-14 95/45- 55).ccls. and etch\$3 and isostatic	US-PGPUB; USPAT	OR	OFF	2008/08/15 12:02
S19	57	(96/4-14 95/45- 55).ccls. and etch\$3 and sinter\$4	US-PGPUB; USPAT	OR	OFF	2008/08/15 12:03
S24	262	"spin-on" near2 pvd	US-PGPUB; USPAT; USOCR	OR	OFF	2008/08/15 12:26

S25	70	427/369-370. ccls. and etch\$5	US-PGPUB; USPAT; USOCR	OR	OFF	2008/08/15 12:32
S26	152	427/369-370. ccls. and crystal \$7	US-PGPUB; USPAT; USOCR	OR	OFF	2008/08/15 12:33
S27	9	(96/4-14 95/45- 55).ccls. and crystal\$7 with (nitride\$1 carbide\$1)	US-PGPUB; USPAT	OR	OFF	2008/08/15 12:38
S28	37	(96/4-14 95/45- 55).ccls. and crystal\$7 with ceramic\$1	US-PGPUB; USPAT	OR	OFF	2008/08/15 12:39
S29	19	(96/4-14 95/45- 55).ccls. and crystal\$7 with strength	US-PGPUB; USPAT	OR	OFF	2008/08/15 12:42
S31	321	427/372.2.ccls. and (membrane \$1 filter\$1) and crystal\$7	US-PGPUB; USPAT; USOCR	OR	OFF	2008/08/15 12:51
S32	27	427/372.2.ccls. and (membrane \$1 filter\$1) and crystal\$7 same strength	US-PGPUB; USPAT; USOCR	OR	OFF	2008/08/15 12:52
S34	190	cvd near2 crystalline	US-PGPUB; USPAT; USOCR	OR	OFF	2008/08/15 13:05
S35	15	membrane same etch\$3 with silicon and ceramic\$1	EPO; JPO; DERWENT	OR	OFF	2008/08/15 13:27
S36	2	membrane with chamber\$1 and etch\$3 with silicon same ceramic\$1	EPO; JPO; DERWENT	OR	OFF	2008/08/15 13:27

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